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TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT
(Under 37 CFR 1.97(b) or 1.97(c))

Docket No.
WLJ.078

In Re Application Of: **Anand SRINIVASAN**

Serial No.
10/018,809

Filing Date
DEC. 21, 2001

Examiner
TO BE ASSIGNED

Group Art Unit
TO BE ASSIGNED

Title: **IMPROVEMENTS RELATING TO PLASMA ETCHING**

Address to:

Assistant Commissioner for Patents
Washington, D.C. 20231

37 CFR 1.97(b)

1. ☒ The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.

37 CFR 1.97(c)

2. ☐ The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:

☐ the statement specified in 37 CFR 1.97(e);

OR

☐ the fee set forth in 37 CFR 1.17(p).

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Payment of Fee

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

- ☐ A check in the amount of _____ is attached.
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Dated: **MARCH 25, 2002**


Signature

ADAM C. VOLENTINE
REG. NO. 33289

VOLENTINE FRANCOS, PLLC
12200 SUNRISE VALLEY DRIVE, SUITE 150
RESTON, VA 20191

TEL. NO. (703) 715-0870

CC:

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

Docket Number (Optional)
WLJ.078

Application Number
10/018,809

Applicant(s)
Anand SRINIVASAN

Filing Date
12/21/2001

Group Art Unit
TO BE ASSIGNED

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A	5,534,109	07/09/1996	FUJIWARA et al.			
	B	5,527,425	06/18/1996	HOBSON et al.			

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
	C	11-16896	01/22/1999	JAPAN			✓	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	D	C.F. CARLSTROM, et al., "Trimethylamine: Novel source for low damage reactive ion beam etching of InP" Journal of Vacuum Science and Technology B, vol. 17, no. 6, November 1999 (1999-11), pages 2660-2663, XP002150318
	E	ELKIND J L et al., "Reactive Ion Etching of HGCDTE with Methane and Hydrogen" Journal of Vacuum Science and Technology: Part A, US, American Institute of Physics. new Yrok, vo. 10, no. 4, PT I, 1 July 1992 (1992-07-01), pages 1106-1112, XP000296215 ISSN: 0734-2101 page 1106, left-hand column, line 12-line 14.

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.